

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L2	2569	(silicon adj (oxide or dioxide)) and precursor and ozone and nitrogen	US-PGPUB; USPAT	OR	ON	2007/09/15 08:49
L3	576	2 and (ozone with nitrogen)	US-PGPUB; USPAT	OR	ON	2007/09/15 08:48
L4	278	3 and @ad<"20020818"	US-PGPUB; USPAT	OR	ON	2007/09/15 09:50
L5	107	4 and ((forming or formation or depositing or deposition or making) with (silicon adj (oxide or dioxide)))	US-PGPUB; USPAT	OR	ON	2007/09/15 10:32
L6	19	((silicon with precursor) with (Si with N with R)) and ((forming or formation or depositing or deposition or making) with (silicon adj (oxide or dioxide)))	US-PGPUB; USPAT	OR	ON	2007/09/15 09:49
L7	4	6 and @ad<"20020818"	US-PGPUB; USPAT	OR	ON	2007/09/15 09:48
L8	468	((silicon with precursor) with (hydrogen or alkyl or halogen)) and ((forming or formation or depositing or deposition or making) with (silicon adj (oxide or dioxide)))	US-PGPUB; USPAT	OR	ON	2007/09/15 10:07
L9	191	8 and @ad<"20020818"	US-PGPUB; USPAT	OR	ON	2007/09/15 10:32
L10	232	((silicon with precursor) same (alkyl or (cyclic adj alkyls) or halogen)) and ((forming or formation or depositing or deposition or making) with (silicon adj (oxide or dioxide)))	US-PGPUB; USPAT	OR	ON	2007/09/15 10:11
L11	91	10 and @ad<"20020818"	US-PGPUB; USPAT	OR	ON	2007/09/15 10:11
L12	19	11 not 9	US-PGPUB; USPAT	OR	ON	2007/09/15 10:11
L13	17	12 not 4	US-PGPUB; USPAT	OR	ON	2007/09/15 10:11
L14	415	((silicon with precursor) same (alkyl or (cyclic adj alkyls) or halogen)) same formula	US-PGPUB; USPAT	OR	ON	2007/09/15 10:11
L15	240	14 and @ad<"20020818"	US-PGPUB; USPAT	OR	ON	2007/09/15 10:11
L16	218	15 not 9	US-PGPUB; USPAT	OR	ON	2007/09/15 10:11
L17	218	16 not 4	US-PGPUB; USPAT	OR	ON	2007/09/15 10:12

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L18	212	17 not 13	US-PGPUB; USPAT	OR	ON	2007/09/15 10:18
L23	1	Si near "NR.sup.1R.sup.2" near "sub.4-wL.sub.w"	US-PGPUB; USPAT	OR	ON	2007/09/15 10:21
L24	0	Si near "NR.sup.1R.sup.2" near "sub.4-wL.sub.w"	USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/15 10:21
L25	167	427/255.18,255.17,255.27.ccls. and ((forming or formation or depositing or deposition or making) with (silicon adj (oxide or dioxide)))	US-PGPUB; USPAT	OR	ON	2007/09/15 10:32
L26	144	25 and @ad<"20020818"	US-PGPUB; USPAT	OR	ON	2007/09/15 10:32
L27	52	26 and precursor	US-PGPUB; USPAT	OR	ON	2007/09/15 10:33